HE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Applicant:

Leonard C. Pipes et al.

Art Unit:

2812

Serial No.:

10/764,751

99999999 Examiner:

Stanetta D. Isaac

Filed:

January 26, 2004

Atty Docket: ITL.0851D1US

P15016D

For:

Implanting Ions in Shallow

Trench Isolation Structures

Assignee:

Intel Corporation

Mail Stop Amendment Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

REPLY TO PAPER NO. 0305

Sir:

In response to the office action mailed March 25, 2005, please amend the abovereferenced patent application as follows:

Date of Deposit: May 26, 2005

I hereby certify under 37 CFR 1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated above and is addressed/to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.